

<b>Form 1449 (Modified)</b>  <b>Information Disclosure Statement By Applicant</b>  (Use Several Sheets if Necessary)	<b>Atty Docket No.</b>	GENSP109
	<b>Application No.:</b>	10/726,441
	<b>Applicant</b>	Kobayashi
	<b>Filing Date</b>	12/02/03
	<b>Group</b>	2623
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**U.S. Patent Documents**

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	1.	2001/0038387	11/08/01	Tomooka et al.			11/29/00
	2.	2002/0085582	07/04/02	Kim			12/27/01
	3.	2002/0136219	09/26/02	Ding et al.			09/26/02
	4.	2002/0149617 A1	10-17-02	Becker			03-28-02
	5.	2002/0190978	12/19/02	Agarwal et al.			09/15/99
	6.	2004/0243905	12/02/04	Merritt			05/30/03
	7.	2007/0140298	06/21/07	Eng			02/02/07
	8.	4,796,203	01/03/89	Roberts			08/26/86
	9.	5,625,379	04/29/97	Reinert et al.			03/13/95
	10.	5,739,803	04-14-98	Neugebauer			01-24-94
	11.	5,745,837	04/28/98	Fuhrmann			03/14/96
	12.	5,852,630	12-22-98	Langberg et al.			03/30/98
	13.	5,918,002	06/29/99	Klemets et al.			03/04/97
	14.	6,020,901	02-01-00	Lavelle et al.			06-30-97
	15.	6,038,000	03/14/00	HURST, JR.			12/23/97
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	18.	6,154,225	11/28/00	KOU ET AL.			10/11/96
	19.	6,175,573	01/16/01	Togo et al.			09/30/97
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	22.	6,446,130	09/03/02	Grapes			03/16/99
	23.	6,765,931	07/20/04	Rabenko et al.			04/13/00
	24.	6,909,442	06/21/05	Hiyama et al.			08/21/02
	25.	7,075,987	07/11/06	Kim et al.			09/23/02

<b>Examiner</b> /Farley Abad/	<b>Date Considered</b> 09/07/2009
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Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

**ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /F.A./**

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**Foreign Patent or Published Foreign Patent Application**

Examiner Initial		Document No.	Publication Date	Country or Patent Office	Class	Sub- Class	Translation	
							Yes	No
	26.	EP 078 8048	06/08/97	EP				
	27.	EP 1 089 503	04/04/01	EP				
	28.	JP03-153299	07/01/91	JP				
	29.	11175045	07-02-99	JP				
	30.	JP 2001 218082	08/10/01	JP				
	31.	JP 2002 304168	10/18/02	JP				
	32.	WO 98/41008	09-17-98	PCT				
	33.	WO95/000917	01/05/95	PCT				
	34.	WO00/020974	04/13/00	PCT				

**Other Documents**

Examiner Initial	No.	Author, Title, Place (e.g. Journal) of Publication, Date
	35.	Office Action mailed 12/5/06 from Application No. 10/726,802 (GENSP014)
	36.	Austrian Search and Exam Report dated February 16, 2007 issued in corresponding Singapore Application No. 200402060-8 (GENSP109SG)
	37.	Office Action mailed July 9, 2007 from related US Application No. 10/726,895. (GENSP108)
	38.	
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